

<u>DB Name</u>	<u>Query</u>	<u>Hit Count</u>	<u>Set Name</u>
USPT,PGPB,JPAB,EPAB,DWPL,TDBD	4563367.pn. and (fluorine or fluoride)	1	L15
USPT,PGPB,JPAB,EPAB,DWPL,TDBD	L12 and (clean\$3 with window)	97	L14
USPT,PGPB,JPAB,EPAB,DWPL,TDBD	L12 and (window)	1027	L13
USPT,PGPB,JPAB,EPAB,DWPL,TDBD	L11 and (fluoride or tri-fluoride or trifluoride or fluorine) and gas\$3	3558	L12
USPT,PGPB,JPAB,EPAB,DWPL,TDBD	((clean\$3 or etch\$3 or remov\$4) with (chamber or wall\$1 or reactor)) and (plasma or PECVD) and (opening\$1 or hole\$1 or orifice\$1 or head or showerhead)	15836	L11
USPT,PGPB,JPAB,EPAB,DWPL,TDBD	(clean\$3 near3 chamber) and PECVD and (opening\$1 or hole\$1 or orifice\$1 or head or showerhead)	276	L10
USPT,PGPB,JPAB,EPAB,DWPL,TDBD	((nitrogen adj fluoride) or NF3) and CVD and electrode\$1	144	L9
USPT,PGPB,JPAB,EPAB,DWPL,TDBD	(nitrogen adj fluoride) and CVD and electrode\$1	83	L8
USPT,PGPB,JPAB,EPAB,DWPL,TDBD	(PHCVD or (photon-induced adj CVD) or (photo adj CVD)) and (PECVD or plasma) and (SiN or nitride)	288	L7
USPT,PGPB,JPAB,EPAB,DWPL,TDBD	15 AND fluoride	2	L6
USPT,PGPB,JPAB,EPAB,DWPL,TDBD	4529474.PN.	3	L5
USPT,PGPB,JPAB,EPAB,DWPL,TDBD	CLEAN\$3 WITH (nf3 OR (NITROGEN ADJ (FLUORIDE OR FLOURIDE)))	178	L4
PGPB,JPAB,EPAB,DWPL,TDBD	(PHCVD or (photon-induced adj CVD) or (photo adj CVD)) and (SiN or (Silicon adj nitride)) and oxide\$1	19	L3
USPT	(hyper and light).ti.	1	L2
USPT	(PHCVD or (photon-induced adj CVD) or (photo adj CVD)) and (SiN or (Silicon adj nitride)) and oxide\$1	211	L1